





Quality assurance of pixel detectors for the CMS Phase I upgrade

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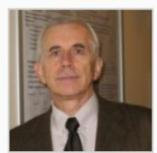
Who we are: CMS Upgrade Group



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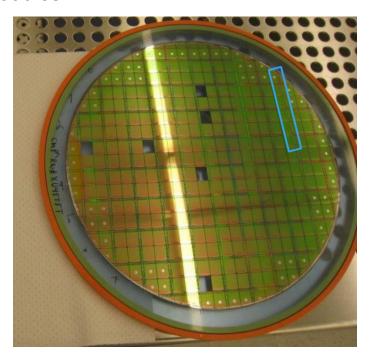
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CMS Phase I Upgrade in Finland

- → Finland has committed to deliver in-kind 50% on pixel modules of CMS Layer3.
- → 4000 read-out ASICs will be flip-chip bonded in Micronova (Espoo, Finland) by Advacam Oy resulting in 240 silicon pixel detector modules with >16M channels.
- → The responsibility of the Helsinki Institute of Physics CMS Upgrade group is the quality assurance of these pixel detector modules.

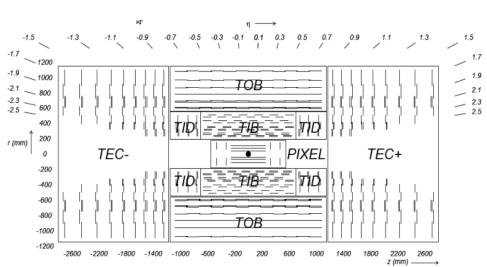




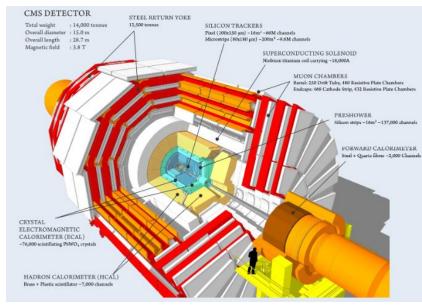


Why CMS pixel detector needs to be upgraded?

- Pixel detector is the innermost detector in CMS experiment
- Considerable increase of data rates requires modifications in the readout chip (ROC) in order to minimize data losses
- Other improvements:
 - +1 innermost layer into Barrel Pixel (BPIX)
 - Number of channels 48 M > 79 M





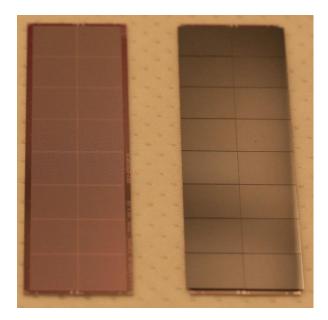


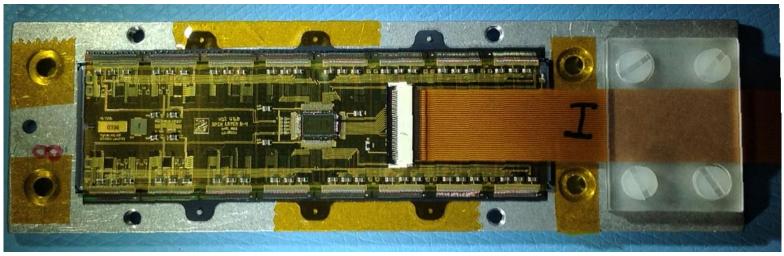
Pictures: CERN

CMS pixel module

- → The CMS pixel detector module consist of a sensor and 16 Read Out Chips (ROC) flip-chip bonded together.
- → Total number of pixels in one module is 16×80×52= 66560.

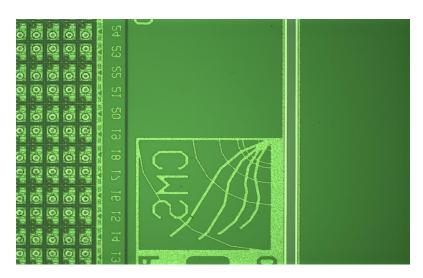
<0.1% of dead channels is acceptable

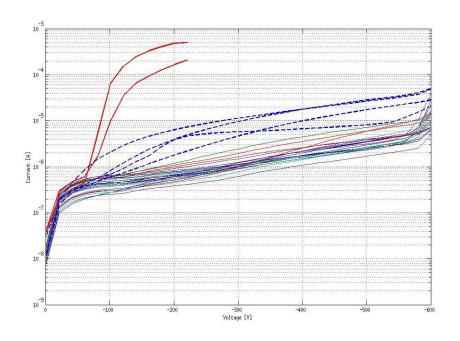


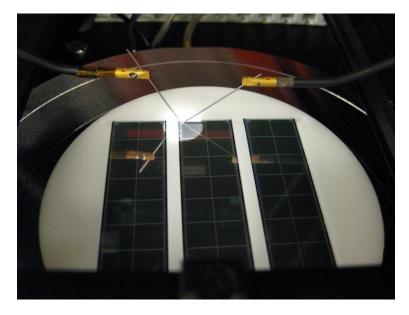


Quality Assurance before flip-chip bonding

- → Flip chip bonding and assembled components are expensive.
- → Sensor and ROC quality must be assured prior the flip-chip bonding.
- → Each ROC is electrically tested after receiving the wafer from the manufacturer.
- → IV measurements of sensors are performed before dicing the wafer, after the dicing and once more after the flip-chip bonding.

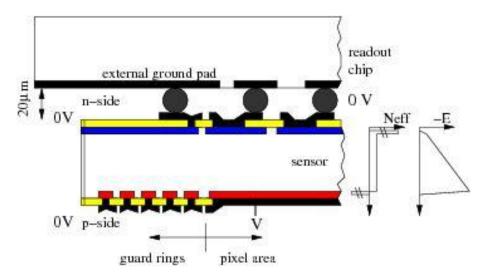


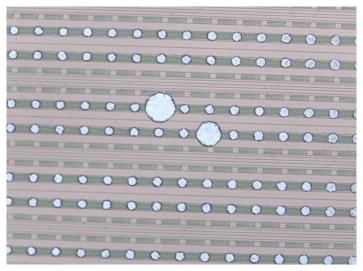




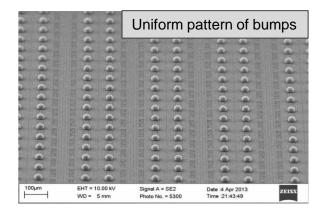
Flip-chip bonding

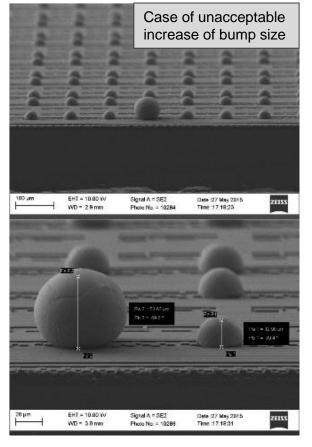
In flip-chip bonding technology the ROC and the sensors are connected with solder bumps





Variance in size of bump may result in bonding failures and short-circuiting after the bonding

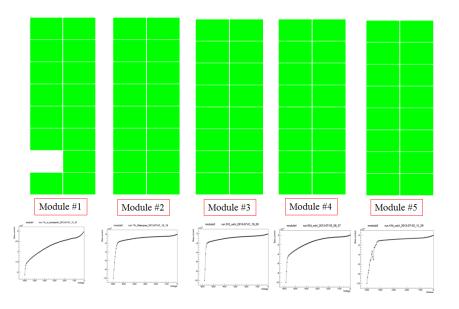


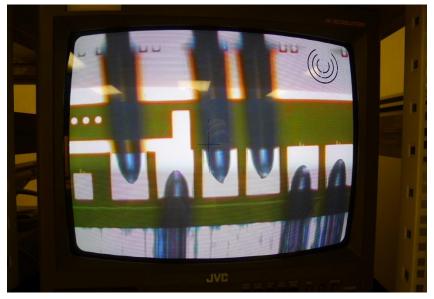


Quality Assurance after flip-chip bonding

- Replacement of disqualified sensors is very complicated
- → One problematic ROC per module means the whole module with 16 ROC chips has to be discarded and replaced

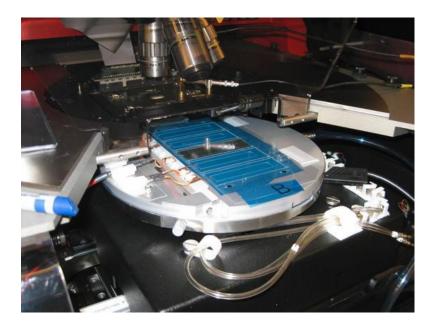






Test setup for the flip-chip bonded modules









Summary

- → Advacam has produced 88 flip-chip bonded modules of the 240 modules required from Finland for the CMS Phase I pixel upgrade.
- → 71 of these modules are classified as class A
- → 2 are classified as class C [failed] due to the high leakage current on sensor
- → 15 have problematic ROC which can be replaced

The first quality assurance step after producing the flip chip bonded module is extremely important as at this phase a possibly malfunctioning readout circuit can still be replaced.